

**PATENT** 5589-06800/P1270

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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88888

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In re Application of: Shi et al.

Filed: October 31, 2003

Serial No. 10/698,222

For:

NON-CONTACT METHODS FOR

MEASURING ELECTRICAL

THICKNESS AND DETERMINING

NITROGEN CONTENT OF

**INSULATING FILMS** 

Group Art Unit: 2863 Examiner: Le, Toan M.

Atty. Dkt. No. 5589-06800 P1270

I hereby certify that this correspondence is being transmitted via facsimile or deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-

1450 on the date indicated below:

6-30-05

Date

Barnela Derik

## AMENDMENT; RESPONSE TO OFFICE ACTION MAILED APRIL 5, 2005

MS: Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed April 5, 2005 to further highlight reasons why the application is in condition for allowance.

Amendments to the Drawings begin on page 2 of this paper.

Remarks begin on page 3 of this paper.